

Notice of References Cited	Application/Control No. 10/784,289	Applicant(s)/Patent Under Reexamination FUJITA ET AL.	
	Examiner Leonard J. McCreary, Jr.	Art Unit 3616	Page 1 of 2

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6688638	2-2001	Schutz	
*	B	US-5692770	12-1997	Scharboneau et al	
*	C	US-5244230	9-1993	Komiya et al	
*	D	US-6783150	8-2004	Anlgvist	
*	E	US-6874808	4-2005	Mahath et al	
*	F	US-200200068369	6-2002	Scherer et al.	
*	G	US-6719324	4-2004	Albers et al	
*	H	US-6474682	11-2002	Ikeda et al.	
*	I	US-6196573	3-2001	Worrell et al.	
*	J	US-6036223	3-2000	Worrell et al.	
*	K	US-20030184062	10-2003	Albers et al	
*	L	US-20030173759	9-2003	Grenier	
*	M	US-20040004344	01/2004	Kim et al.	

TAM
11-29-04

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.